



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Kazuhiro HARADA, et al.

Serial No.: 10/769,367

Filed: January 30, 2004

Art Unit: To be Assigned

Examiner: To be Assigned

Attorney Docket No.: JG-SU-5196/500577.20055

Customer No.: 026418

**METHOD OF MANUFACTURING
SILICON SINGLE CRYSTAL AND
SILICON SINGLE CRYSTAL
MANUFACTURED BY THE
METHOD**

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

SECOND PRELIMINARY AMENDMENT

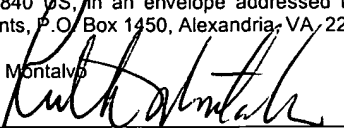
Sir:

The above-identified application is filed concurrently herewith, please amend the specification and claims as follows:

Amendments to the specification begin on page 2 of this paper.

Amendments to the Abstract begins on page 3 of this paper.

Remarks/Arguments begin on page 4 of this paper.

CERTIFICATE OF MAILING	
I hereby certify that this paper (along with any document referred to as being attached or enclosed) is being:	
EXPRESS MAIL <input checked="" type="checkbox"/> deposited with the United States Postal Service on August 10, 2005, with sufficient postage as Express Mail, No. EV 398 732 840 US, in an envelope addressed to, Commissioner for Patents, P.O. Box 1450, Alexandria, VA, 22313-1450. Ruth Montalvo  (Signature of person mailing paper or fee)	FACSIMILE <input type="checkbox"/> transmitted by facsimile on [date] to the U.S. Patent and Trademark Office. Type Signature Name (Signature of person mailing paper or fee)